

Our ref.: KON-2020

Client's ref.: P6636-001-0000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Hiromoto, II, :
et al

Art Unit: 1792

Appln. No.: 10/544,084 :

Examiner: David P.
TUROC

Filed: July 28, 2005 :

For: FILM FORMING METHOD AND :
SUBSTRATE HAVING A FILM :
FORMED BY THE METHOD :

Dated: May 18, 2009

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Confirmation #9413

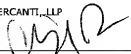
SUBMISSION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE

I hereby certify that this correspondence is being EFS-Web or facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 18, 2009.

LUCAS & MERCANTI, LLP

BY: 
Christina M. Jordan, Reg. #61,098

S i r:

This is a Submission filed concurrently with a Request for Continued Examination in the above-identified case. Attached hereto are Claim Amendments, Certified English Translation of the claims of the Japanese Priority Document JP 2003-197799 and Remarks, each starting on a separate page.